

## RESULTS AND DISCUSSION

Chalcogenide glasses have been studied for several years because of their interesting in the field of electronics . The present work deals with dc electrical conductivity measurements and structure analysis, for Ge Te X (where X = Se. or In) . These composition are close to the eutectic point of Ge Te binary alloy ( $\text{Te}_{83}\text{Ge}_{17}$ ) . The effect of aging on the electrical conductivity and structure transformation are presented in this chapter . In section 3.1 the electrical conductivity , I-V characteristics and structure transformations will be given for  $\text{Ge}_{20}\text{Se}_{12}\text{Te}_{68}$  chalcogenide . Moreover in section 3.2 the electrical conductivity , I - V characteristics and structure transformation will be given for  $\text{Ge}_{27}\text{Se}_{11}\text{Te}_{62}$  system. Finally in section 3.3 also the electrical conductivity, I-V characteristics and structure transformation will be given for  $\text{Ge}_{15}\text{Te}_{75}\text{In}_{10}$  system.

### 3.1- Electrical conduction and microstructure for system

#### $\text{Ge}_{20}\text{Se}_{12}\text{Te}_{68}$ :-

The effect of the thermal annealing on the electrical conductivity of  $\text{Ge}_{20}\text{Se}_{12}\text{Te}_{68}$  system is studied

to show the stability of these materials as devices . Samples of  $2 \times 2 \times 1 \text{ mm}^3$  dimension are prepared according to the mentioned method (chapter II). The samples are annealed at two degrees of temperature , the first is  $423^\circ\text{K}$  (before the crystallization temperature) and the second is  $473^\circ\text{K}$  ( the crystallization temperature). The samples are divided into two sets . Each sample of the first set is annealed at the desired temperature  $423^\circ\text{K}$  for a certain period, and left to cool slowly to room temperature . Then the conductivity  $\sigma$  , is measured starting from room temperature in steps up to  $473^\circ\text{K}$ . Figure (3.1) illustrates the temperature dependence of  $\sigma$  for the first set of samples . The conductivity  $\sigma$  obeys Arrhenious relation in the form : -

$$\sigma = \sigma_0 \exp (-\Delta E / KT) \quad 3.1$$

where  $\sigma_0$  is constant,  $\Delta E$  the activation energy and  $K$  is Boltzman constant . The calculated values of  $\Delta E$  as well as the room temperature conductivity after annealing are given in Table (3.1) . It is clear that the room temperature conductivity  $\sigma_r$  increases with the

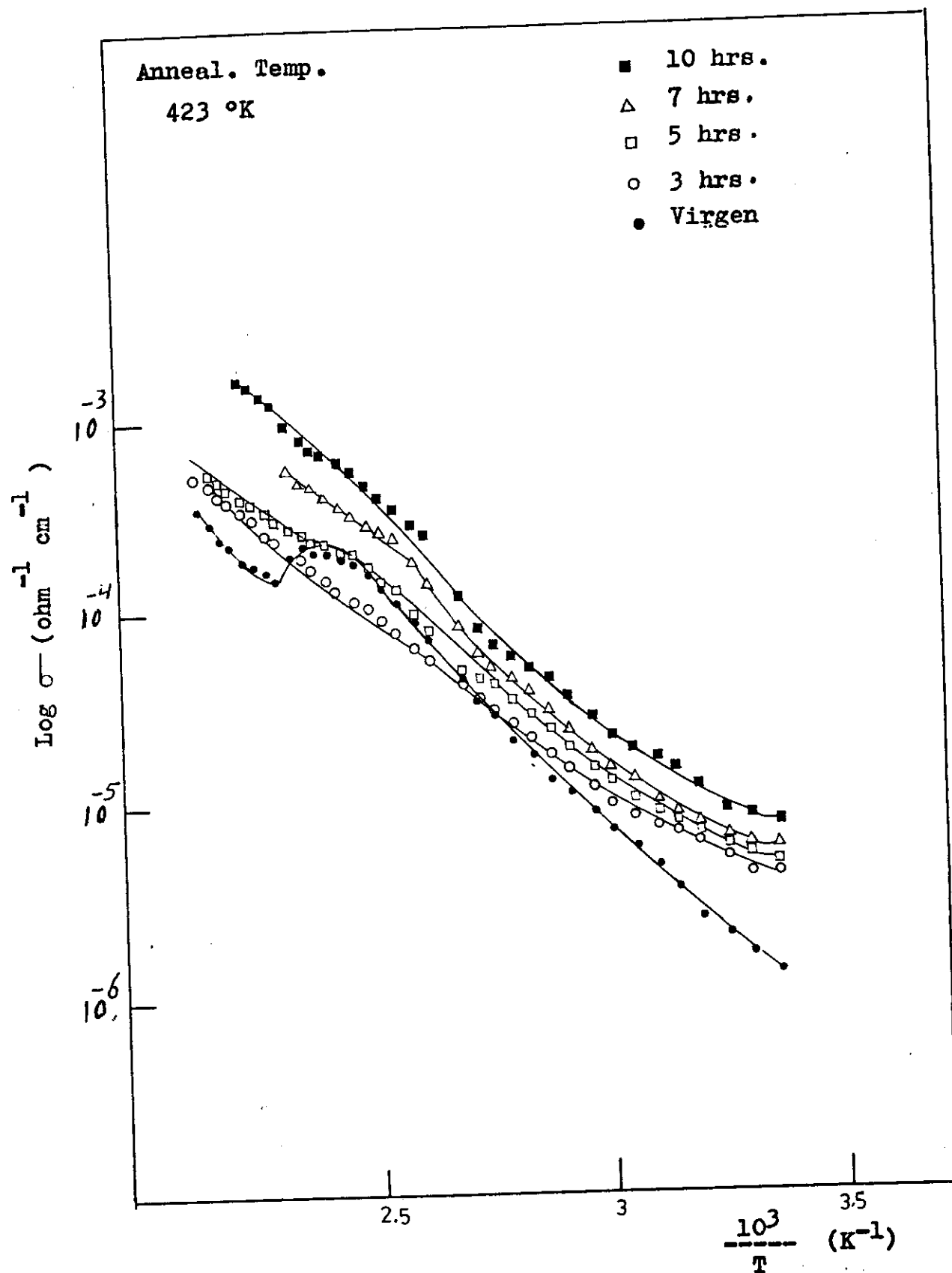


Fig.(3.1): Log  $\sigma$  Vs  $\frac{10^3}{T}$  for Ge<sub>20</sub> Se<sub>12</sub> Te<sub>68</sub>

samples annealed at 423°K

Table (3.1)

Effect of annealing temperatures and annealing time on the activation energy ( $\Delta E$ ) and electrical conductivity at room temperature ( $\sigma_r$ ) for  $\text{Ge}_{20}\text{Se}_{12}\text{Te}_{68}$  system.

Anneal. temp. °K	Anneal. time. hrs.	$\Delta E$ eV	$\sigma_r$ ohm <sup>-1</sup> cm <sup>-1</sup>
423	0	0.49	$1.4 \times 10^{-6}$
	3	0.38	$4.2 \times 10^{-6}$
	5	0.37	$5.0 \times 10^{-6}$
	7	0.43	$6.0 \times 10^{-6}$
	10	0.44	$7.7 \times 10^{-6}$
473	0	0.49	$1.4 \times 10^{-6}$
	3	0.06	$1.3 \times 10^{-4}$
	5	0.04	$2.2 \times 10^{-4}$
	10	0.04	$4.0 \times 10^{-4}$
	20	0.045	$4.8 \times 10^{-4}$

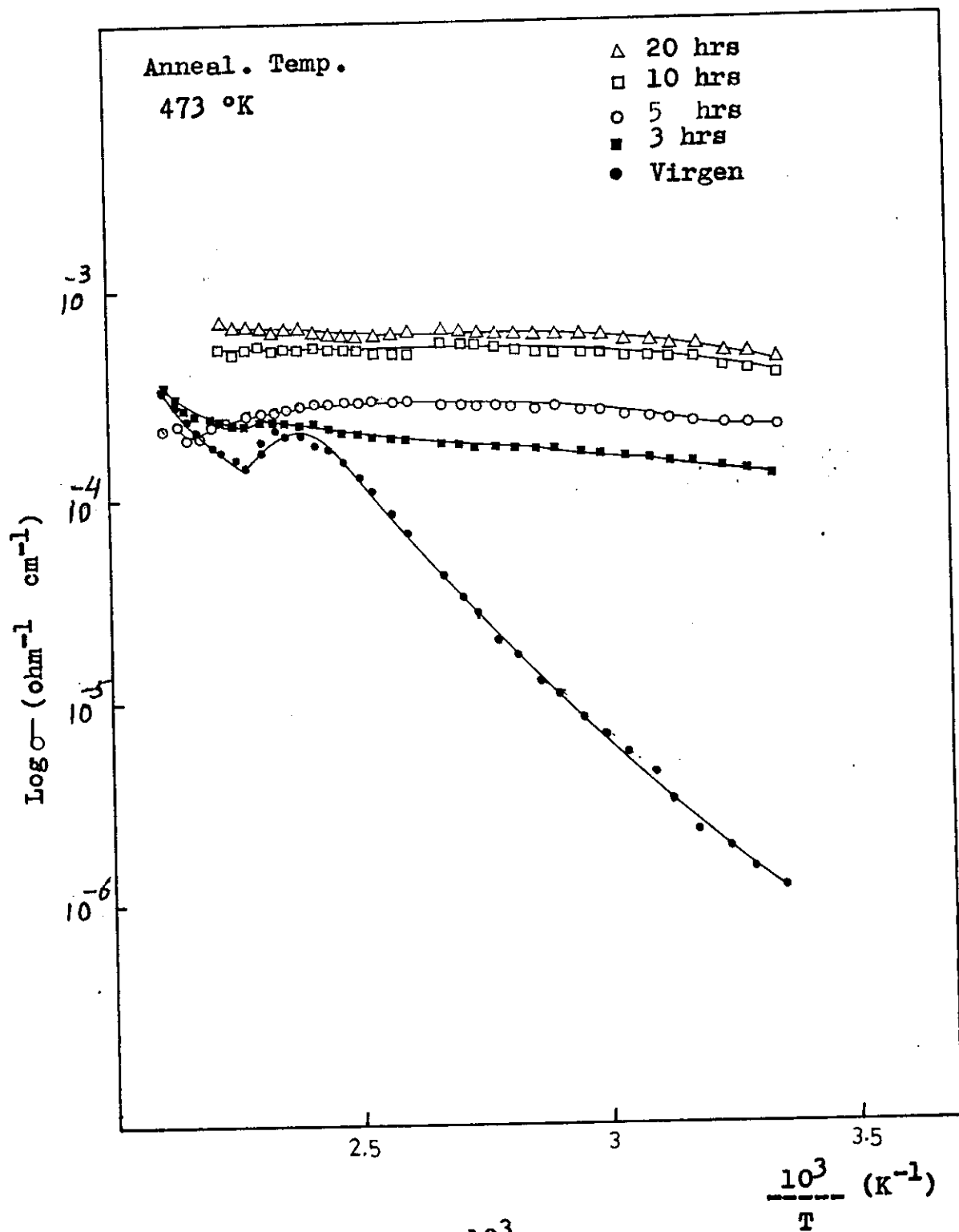


Fig.(3.2):  $\log \sigma$ -Vs  $\frac{10^3}{T}$  for Ge<sub>20</sub>Se<sub>12</sub>Te<sub>68</sub> samples annealed at 473 °K .

It is clear that the extension of annealing temperature to  $T_c$  (crystallization temperature) enhances the amorphous - crystalline transformation. From the above discussion, it is noticed that the decrease in  $\Delta E$  and the increase in  $\sigma_r$  with annealing time is due to the formation of microcrystalline phase, embedded in the amorphous matrix. This phase will act as a conductivity path ways for carrier transport. The time dependence of  $\sigma$  for  $\text{Ge}_{20} \text{Se}_{12} \text{Te}_{68}$  glassy material at the crystallization temperature ( $T_c = 473^\circ\text{K}$ ) was conducted to study the crystallization kinetics of this system. Figure (3.3) shows the time dependence of  $\sigma$ , the  $\sigma$ -values increases monotonically with the time of annealing. The crystallization kinetics process could studied from (conductivity - time relation) by applying Avrami's equation (36,44) in the form :-

$$\theta = \exp (- B t^n) \quad 3.2$$

where  $\theta$  is the amount of material left uncrystallized at time  $t$ ,  $n$  is an integer constant depending on the mechanism of crystallization,  $B$  is the crystallization

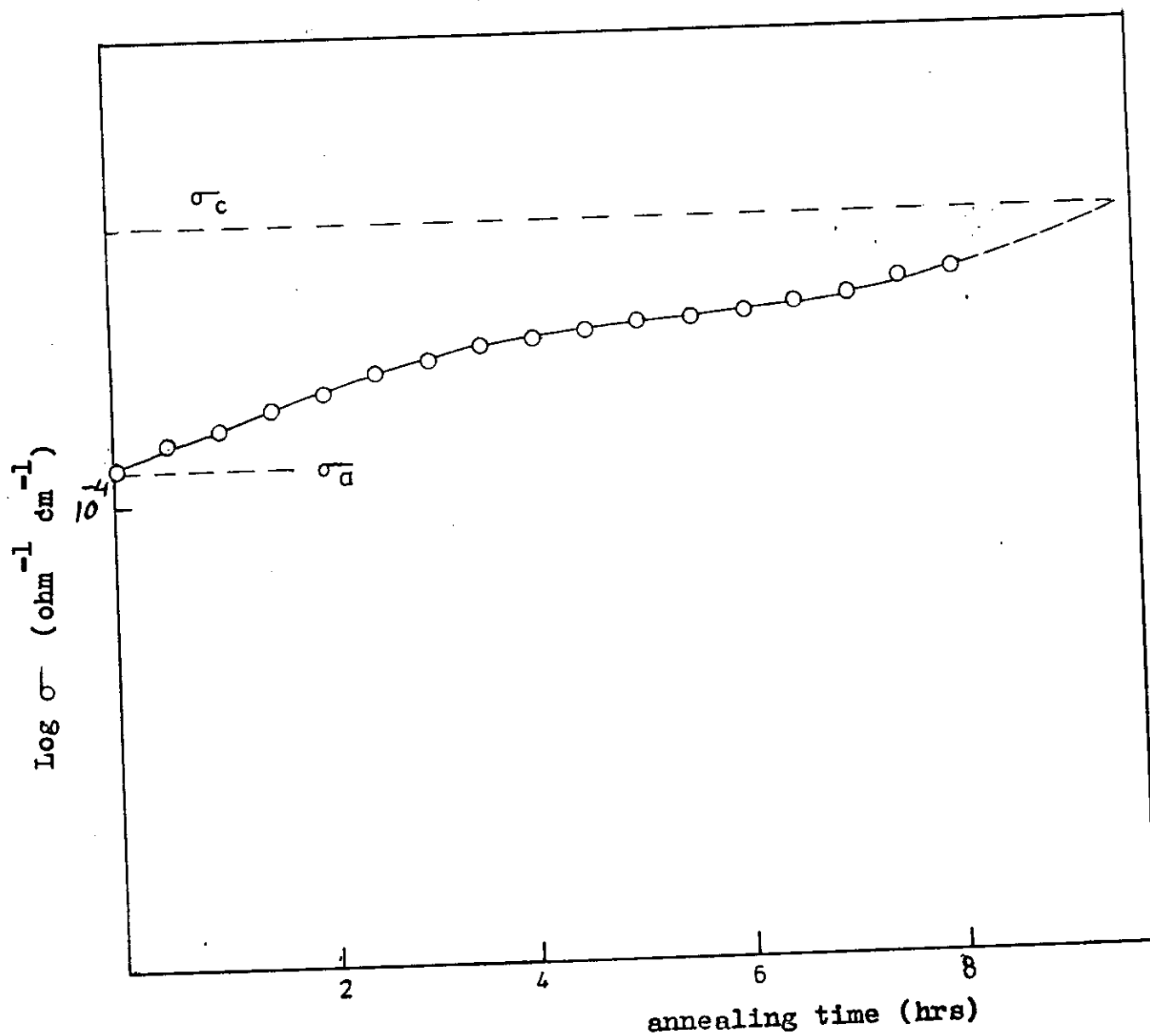


Fig.(3.3):  $\text{Log } \sigma$  Vs annealing time for  $\text{Ge}_{20}\text{Se}_{12}\text{Te}_{68}$   
at 473 °K.